

7-27-01 A

EXPRESS MAIL NO. EL846074315US

Docket No. 57A 3127
Date: July 26, 2001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

Transmitted herewith for filing is the patent application for inventor(s):

YOSHIKAZU NAKAYAMA and AKIO HARADA

For: LITHOGRAPHIC METHOD USING ULTRA-FINE PROBE NEEDLE

Also enclosed are:

- ☒ 11 sheets of drawings
- ☐ Certified copy of Japanese Patent Application No. _____ of _____ on which Convention priority is claimed
- ☒ Declaration and Power of Attorney
- ☐ Information Disclosure Statement by Applicant
- ☐ Preliminary Amendment
- ☒ An assignment of the invention to YOSHIKAZU NAKAYAMA and DAIKEN CHEMICAL CO., LTD.
- ☒ Applicant claims Small Entity Status

CALCULATION OF FEES								
ITEM		TOTAL NO. OF CLAIMS		NO. OF CLAIMS OVER BASE	LG/SM \$ ENTITY FEE		\$ AMOUNT	\$ FEE
A	TOTAL CLAIMS FEE	11	-20	0	LG=\$18 SM=\$9	\$9	\$ 0	
B	INDEPENDENT CLAIMS FEE*	1	-3	0	LG=\$80 SM=\$40	\$40	\$ 0	
C	SUBTOTAL - ADDITIONAL CLAIMS FEE (ADD FINAL COLUMN IN LINES A + B)							\$ 0
D	MULTIPLE-DEPENDENT CLAIMS FEE				LARGE ENTITY FEE = \$270 SMALL ENTITY FEE = \$135		\$ 135	
E	BASIC FEE				LARGE ENTITY FEE = \$710 SMALL ENTITY FEE = \$355		\$ 355	
F	TOTAL FILING FEE (ADD TOTALS FOR LINES C, D, AND E)							\$ 490
G	ASSIGNMENT RECORDING FEE							\$ 40
	*LIST INDEPENDENT CLAIMS 1							

- ☒ The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Account No. 11-1445. A duplicate copy of this sheet is enclosed.
- ☒ A check in the amount of \$ 490 to cover the filing fee is enclosed.
- ☒ A check in the amount of \$ 40 to cover Assignment Recordation fee is enclosed.

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Respectfully submitted,
KODA & ANDROLIA

By: William L. Androlia
Reg. No. 27,177

I hereby certify that this correspondence is being deposited with the United States Postal
Service as Express Mail No. EL846074315US addressed to:

Assistant Commissioner for Patents
Washington, D.C. 20231

on July 26, 2001 by Inja Yi.

Dated: 7/26/01

By: Inja Yi

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MIKI

Inventor(s):

YOSHIKAZU NAKAYAMA and AKIO HARADA

For:

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